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## Attorney Docket No.: NEKA 18.612 (100806-00199)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Yoshihisa MATSUBARA et al.

Serial No.: 09/840,386

Filed: April 23, 2001

Title: METHOD FOR MANUFACTURING SEMICONDUCTOR

DEVICE, AND PROCESSING SYSTEM AND

SEMICONDUCTOR DEVICE

Examiner: Lan Vinh Group Art Unit: 1765

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

## RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. 1.116

SIR:

In response to the Office Action mailed on January 21, 2004, the period for responding thereto having been set to expire after April 21, 2004, the period for response not being extended for more than one month, please consider the following remarks: